

## APPLICATION DATA SHEET

### APPLICATION INFORMATION

Application Type:: REGULAR  
Subject Matter:: UTILITY  
CD-ROM or CD-R?: NONE  
Title:: METHOD AND APPARATUS FOR  
FORMING SUBSTRATE FOR  
SEMICONDUCTOR OR THE LIKE  
Attorney Docket Number:: 245651US2  
Total Drawing Sheets:: 7  
Small Entity?: NO

### INVENTOR INFORMATION

Applicant Authority Type:: INVENTOR  
Primary Citizenship Country:: Japan  
Status:: FULL CAPACITY  
Given Name:: Yoshio  
Family Name:: TAKAMI  
City of Residence:: Yokohama-shi  
Country of Residence:: Japan  
Street of Mailing Address:: c/o Advanced LCD Technologies  
Development Center Co., Ltd., 292,  
Yoshida-cho, Totsuka-ku  
City of Mailing Address:: Yokohama-shi  
State or Province of Mailing Address:: Kanagawa-ken  
Country of Mailing Address:: Japan

### CORRESPONDENCE INFORMATION

Correspondence Customer Number:: 22850

### REPRESENTATIVE INFORMATION

Representative Customer Number:: 22850

### FOREIGN PRIORITY INFORMATION

Application Number:	Country:	Filing Date:	Priority Claimed:
2002-341330	Japan	11/25/02	YES